

JC672 U.S. PRO
09/87 [431]

08/31/01	Class	Subclass

U.S. UTILITY Patent Application

O.I.P.E. *Ed*

PATENT DATE

APPLICATION NO.	CONT/PRIOR	CLASS	SUBCLASS	ART UNIT	EXAMINER
09/871431	F	11850	3-5	4734 11850	Zervigon Alexander Zervigon
APPLICANTS	Hong-Sik Byun Gi-Chung Kwon Sung-Weon Lee Hong-Seub Kim				
TITLE	Plasma processing apparatus				

ISSUING CLASSIFICATION

Continued on Issue Slip Inside File Jacket

TERMINAL DISCLAIMER	DRAWINGS			CLAIMS ALLOWED	
	Sheets Drwg.	Figs. Drwg.	Print Fig.	Total Claims	Print Claim for O.G.
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